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**\*BIBDATASHEET\***

Bib Data Sheet

**CONFIRMATION NO. 3735**

SERIAL NUMBER 09/883,922	FILING DATE 06/20/2001  RULE	CLASS 117	GROUP ART UNIT 1765	ATTORNEY DOCKET NO. 010789
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**\*\* CONTINUING DATA \*\*\*\*\*****\*\* FOREIGN APPLICATIONS \*\*\*\*\***

JAPAN 2000-188176 06/22/2000  
 JAPAN 2000-190631 06/26/2000

MA 8/17/04

**IF REQUIRED, FOREIGN FILING LICENSE GRANTED**

\*\* 08/03/2001

Foreign Priority claimed 35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no  <i>[Handwritten Signature]</i> Initials	STATE OR COUNTRY JAPAN	SHEETS DRAWING 5	TOTAL CLAIMS 16	INDEPENDENT CLAIMS 12
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**TITLE**

Method of manufacturing epitaxial wafer and method of producing single crystal as material therefor

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RECEIVED 1772		

